

JFW



Docket No.: 057810-0074

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of	:	Customer Number: 20277
Isao Hasegawa, et al.	:	Confirmation Number: 7087
Application No.: 10/659,346	:	Group Art Unit: 2812
Filed: September 11, 2003	:	Examiner: Schillinger, Laura M.
For: METHOD OF FABRICATING SEMICONDUCTOR DEVICE	:	

**AMENDMENT**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

The following Amendment and Remarks are submitted in response to the Office Action  
dated June 28, 2005.